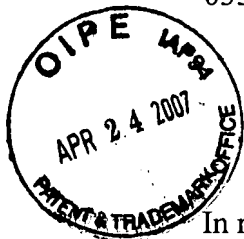


03500.017456

*cgl*  
PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

KAZUHIRO KAGAMI ET AL.

Appln. No.: 10/627,645

Filed: July 28, 2003

For: BASE PATTERN FORMING  
MATERIAL FOR ELECTRODE AND  
WIRING MATERIAL ABSORPTION,  
ELECTRODE AND WIRING FORMING  
METHOD, AND METHOD OF  
MANUFACTURING IMAGE FORMING  
APPARATUS

U.S. Patent No.: 7,115,432 B2

Issued: October 3, 2006

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: Examiner: Hsien-Ming Lee

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: Art Unit: 2823

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**Certificate**  
**APR 30 2007**  
**of Correction**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

The following minor errors have been noted in the above-mentioned patent:

COLUMN 5

Line 40, "patter" should read --pattern--.


COLUMN 7

Line 31, "above" should read --above---.

These errors appear to be relatively insignificant and, therefore, we do not believe it is necessary to request a Certificate of Correction. However, it is requested that this paper be placed in the filewrapper of the above-identified patent.

Patentees' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Jason M. Okun  
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